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<b>Substitute for form 1449A/PTO</b> <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				Applicant Number	10/047,976
				Filing Date	1/13/02
				First Named Inventor	Steven Teig
				Group Art Unit	2825
				Examiner Name	Sick
Sheet	1	of	1	Attorney Docket Number	SPLX.P0084

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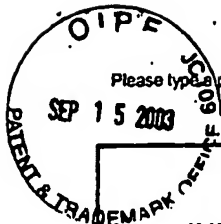
RELATED U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No. <sup>1</sup>	U.S. Patent Document		Date of filing MMDD-YYYY	Name of Patentee or Applicant of Cited Document	Related Application Data
		Number				
VS	1.	2003/0079193		12-07-2001	Steven Teig et al.	Parent application of the parent application (2003/0088844) of the present application.
	2.	2003/0018947		12-07-2001	Steven Teig et al.	Application with some of the same parent provisional applications and with the same specification as the present application except for summary and abstract.
	3.	2002/0147958		10-19-2001	Steven Teig et al.	Parent application per the preliminary amendment dated 2/19/03.
	4.	2003/0063614		01-04-2002	Steven Teig et al.	Application with some of the same parent provisional applications and with the same specification as the present application except for summary and abstract.
	5.	2003/0064559		01-04-2002	Steven Teig et al.	Application with some of the same parent provisional applications and with the same specification as the present application except for summary and abstract.
	6.	2003/0063568		01-04-2002	Steven Teig et al.	Application with some of the same parent provisional applications and with the same specification as the present application except for summary and abstract.
	7.	2003/0101428		01-05-2002	Steven Teig et al.	Continuation of 2003/0079193.
	8.	2002/0166105		01-05-2002	Steven Teig et al.	Continuation of 2003/0079193.
	9.	2003/0043827		01-05-2002	Steven Teig et al.	Continuation of 2003/0079193.
	10.	2003/0023943		01-05-2002	Steven Teig et al.	Continuation of 2003/0079193.
	11.	2003/0066042		01-05-2002	Steven Teig et al.	Continuation of 2003/0079193.
	12.	2002/0174412		01-07-2002	Steven Teig et al.	Continuation of 2003/0079193.
VS	13.	2003/0088844		01-07-2002	Steven Teig et al.	Per the preliminary amendment dated 5/7/03, the present application is a continuation of 2003/0088844, which is a continuation of 2003/0079193.

Examiner Signature	VUTHE SICK	Date Considered	7/7/04
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Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				Application Number	10/047,976
				Filing Date	1/13/02
				First Named Inventor	Steven Teig
				Group Art Unit	2825
				Examiner Name	SLEK
Sheet	2	of	2	Attorney Docket Number	SPLX.P0084

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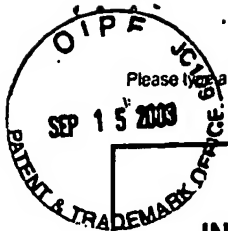
RELATED U.S. PATENT DOCUMENTS					
15	14.	2002/0199165	01-13-2002	Steven Teig et al.	Continuation of 2003/0079193.
	15.	2003/0066043	01-13-2002	Steven Teig et al.	Continuation of 2003/0088844 per preliminary amendment.
	16.	2003/0056187	01-14-2002	Steven Teig et al.	Continuation of 2003/0079193.
	17.	2003/0066044	01-13-2002	Steven Teig et al.	Application with some of the same parent provisional applications and with the same specification as the present application except for summary and abstract.
	18.	2003/0066045	01-13-2002	Steven Teig et al.	Application with some of the same parent provisional applications and with the same specification as the present application except for summary and abstract.
	19.	2002/0133798	12-06-2000	Steven Teig et al.	Application regarding related placement technology
	20.	2002/0100007	12-06-2000	Steven Teig et al.	Application regarding related placement technology
	21.	2002/0073390	12-13-2000	Steven Teig et al.	Application regarding related placement technology
	22.	S/N 09/737,220	12-13-2000	Steven Teig et al.	Application regarding related placement technology
	23.	S/N 09/737,245	12-13-2000	Steven Teig et al.	Application regarding related placement technology
	24.	S/N 09/739,460	12-15-2000	Steven Teig et al.	Application regarding related placement technology
	25.	2002/0124231	12-15-2000	Steven Teig et al.	Application regarding related placement technology
	26.	S/N 09/739,589	12-15-2000	Steven Teig et al.	Application regarding related placement technology
	27.	S/N 09/742,171	12-19-2000	Steven Teig et al.	Application regarding related placement technology
	28.	2003/0121015	12-19-2000	Steven Teig et al.	Application regarding related placement technology
VS	29.	2002/0069397	01-13-2002	Steven Teig et al.	Application regarding related placement technology

Examiner Signature	VUTHE SLEK	Date Considered	7/7/2004
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				<b>Filing Date</b>	1/13/02
				<b>First Named Inventor</b>	Steven Teig
				<b>Group Art Unit</b>	2856
				<b>Examiner Name</b>	S. cell
<b>Sheet</b>	3	<b>of</b>	3	<b>Attorney Docket Number</b>	SPLX.P0084

RELATED U.S. PATENT DOCUMENTS						
VS	30.	2002/0170027		02-20-2002	Steven Teig et al.	Application regarding related placement technology
VS	31.	2002/0157075		02-20-2002	Steven Teig et al.	Application regarding related placement technology
VS	32.	2003/0088841		12-23-2002	Steven Teig et al.	Application regarding related placement technology

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